

03/19/2010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	Attorney Docket No. 2005_1908A
Tatsuya SASAKI et al.	:	Confirmation No. 7391
Serial No. 10/559,815	:	Group Art Unit 1792
Filed March 23, 2006	:	Examiner Sylvia MacArthur
POLISHING APPARATUS AND POLISHING METHOD	:	Mail Stop: AF

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1792

Sir:

In response to the Office Action of December 9, 2009, please amend the above-referenced U.S. patent application as follows: